

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/812,195	CHEN, DANIEL	
Examiner		Art Unit		Page 1 of 1
Jamila O. Williams		3722		

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,722,647	03-1998	Rattaro et al.	269/45
	B	US-6,712,565	03-2004	Wehmeier, Reinhard	408/91
	C	US-2,948,168	08-1960	MCCORMICK RAYNA H	408/69
	D	US-5,634,748	06-1997	Brazell et al.	408/89
	E	US-3,782,847	01-1974	Kulzer, Leonard J.	408/1R
	F	US-3,200,470	08-1965	JOHANN MULLER	408/89
	G	US-5,865,576	02-1999	Arai et al.	409/201
	H	US-5,507,605	04-1996	Bae, Suk-Kyu	408/89
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 57194808 A	11-1982	Japan	SATO, YOSHIKAZU	B23B 39/00
	O	JP 09038955 A	02-1997	Japan	IMAI, KAZUHISA	B28D 01/14
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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